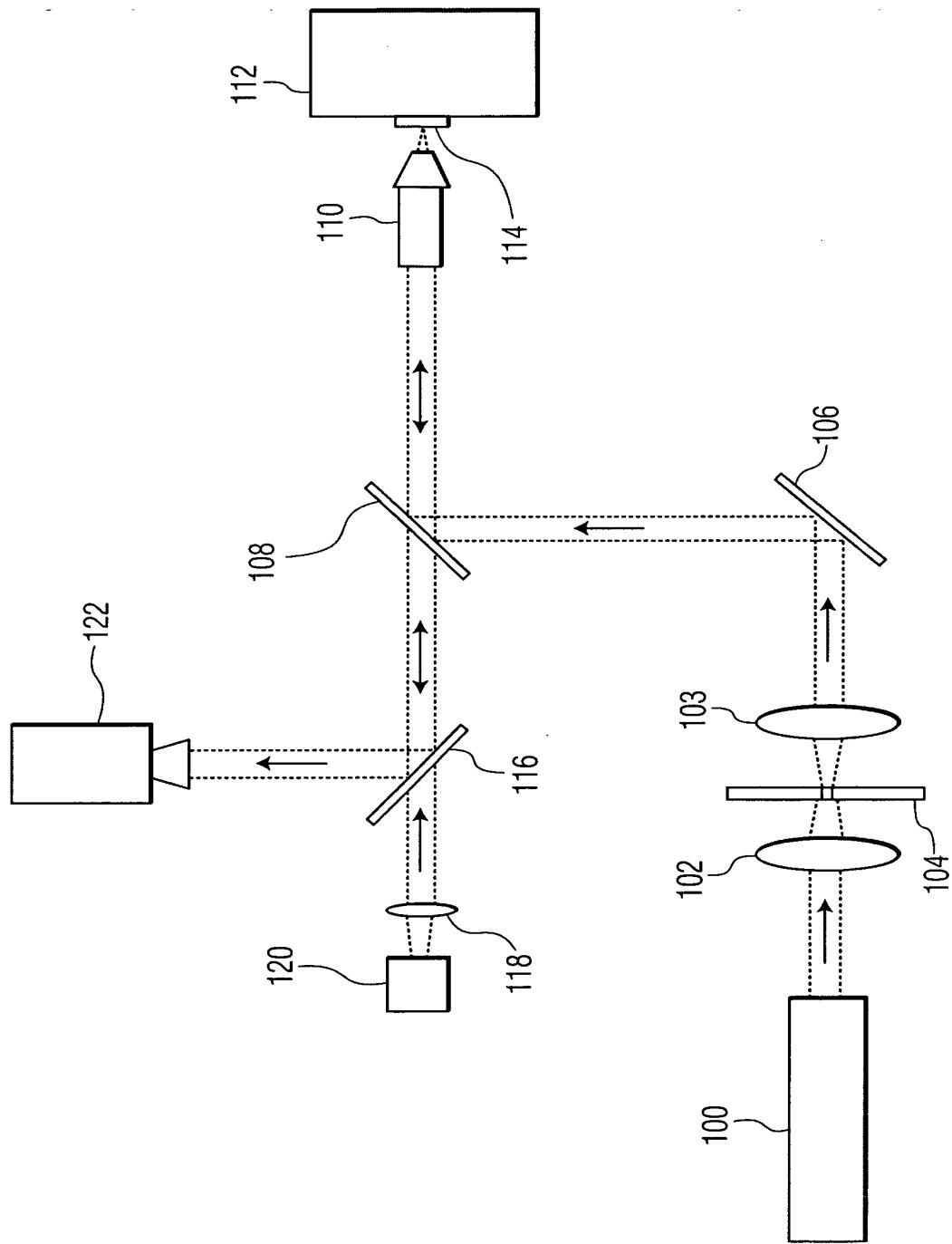




Inventor: Ming Li et al.  
Attorney Docket: MATG-401US  
Title: Ultrafast Laser Direct Writing Method For Modifying Existing Microstructures On A Submicron Scale  
Application No.: 10/790,401

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FIG. 1



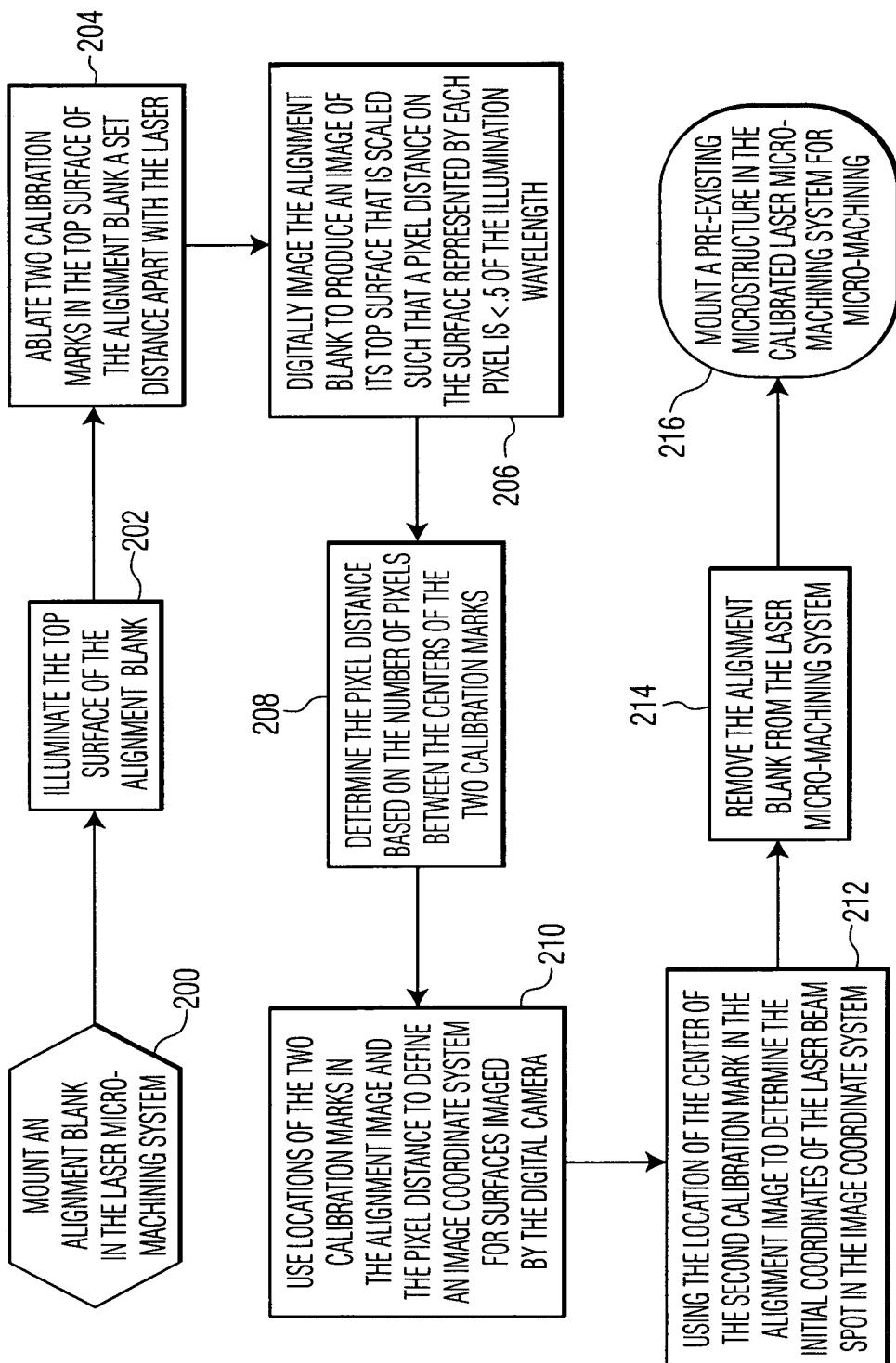


FIG. 2

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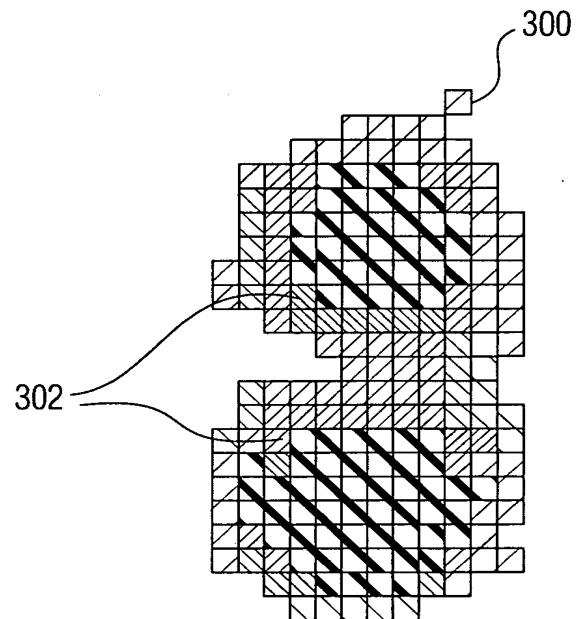


FIG. 3A

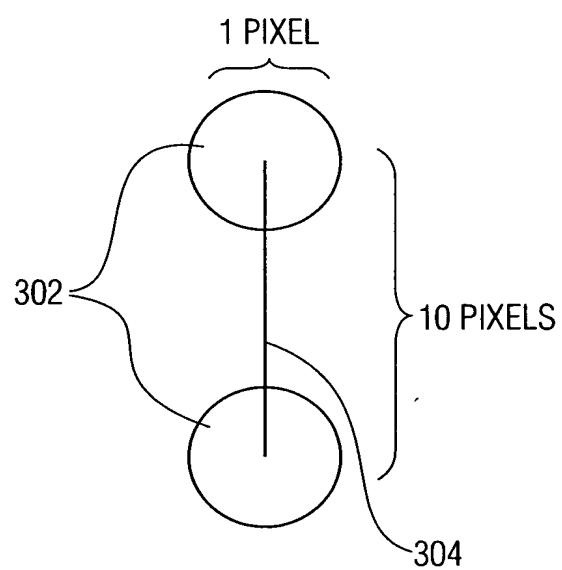


FIG. 3B

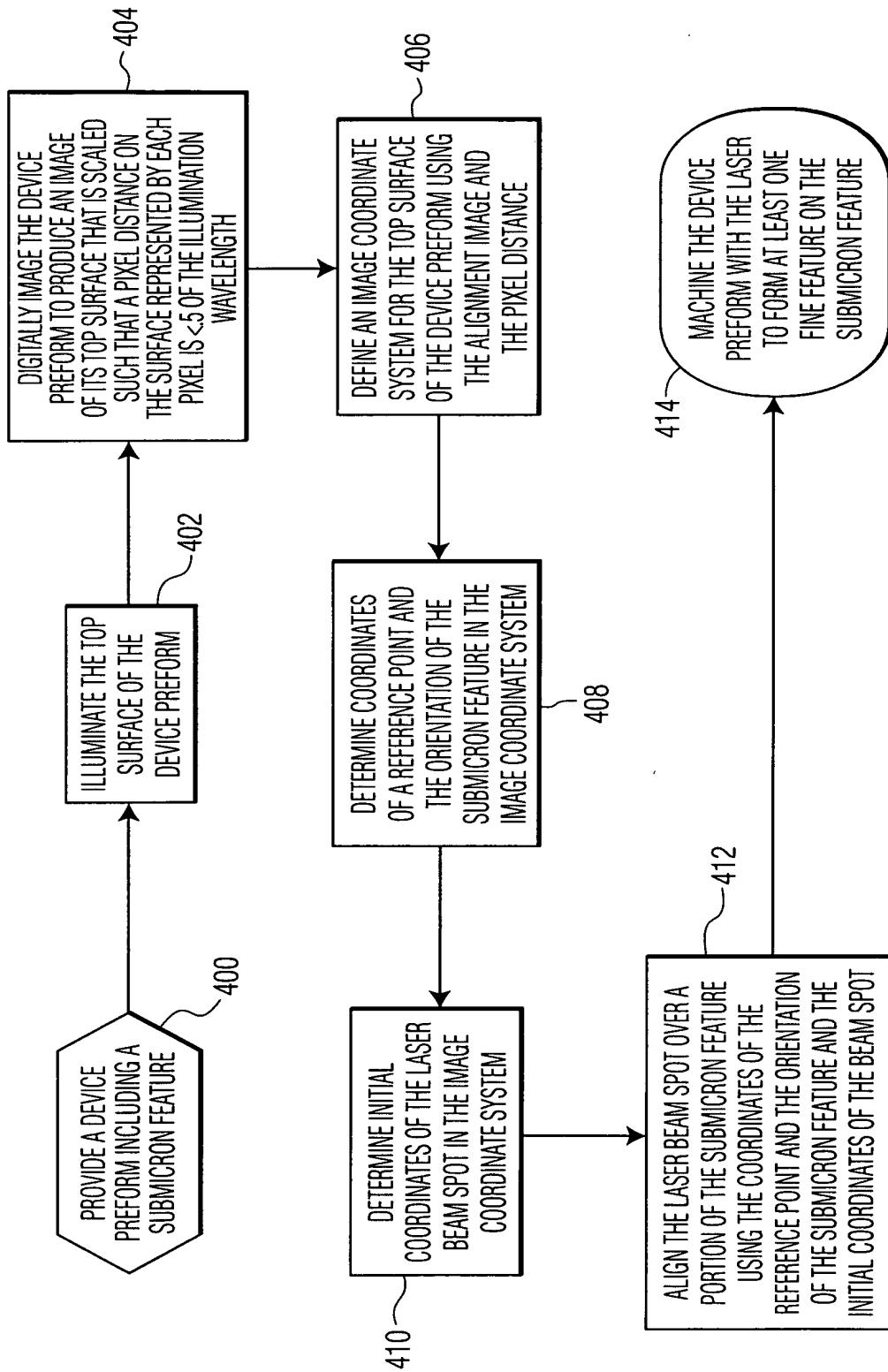


FIG. 4

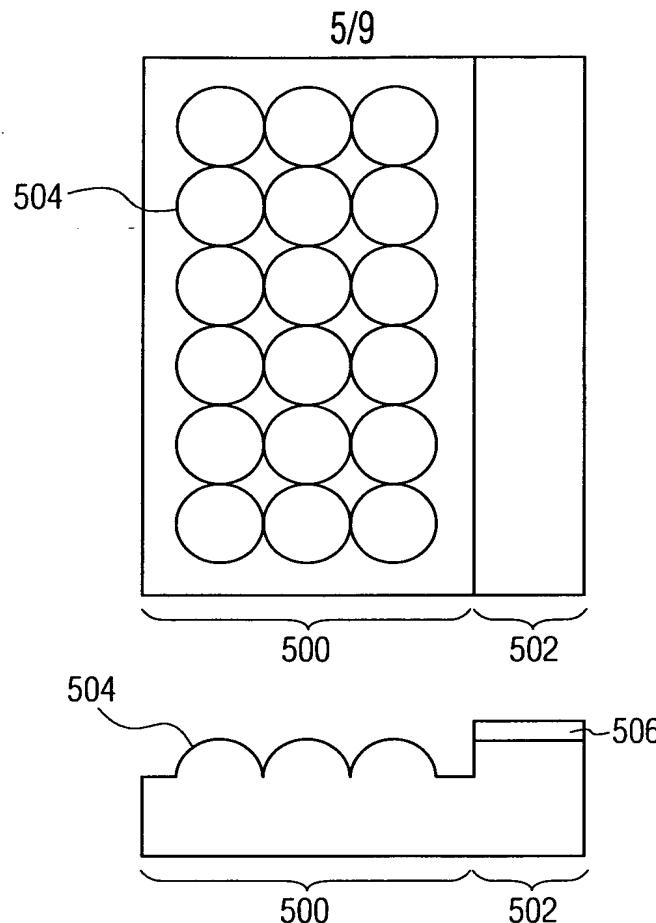


FIG. 5A

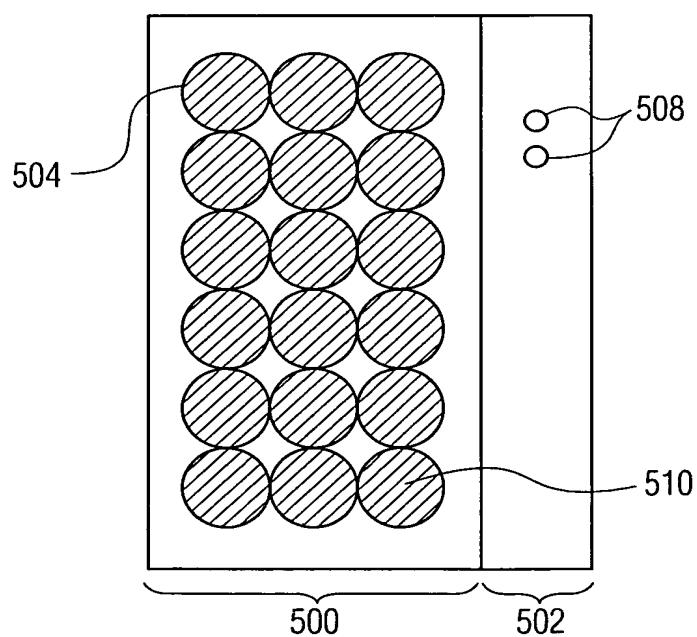


FIG. 5C

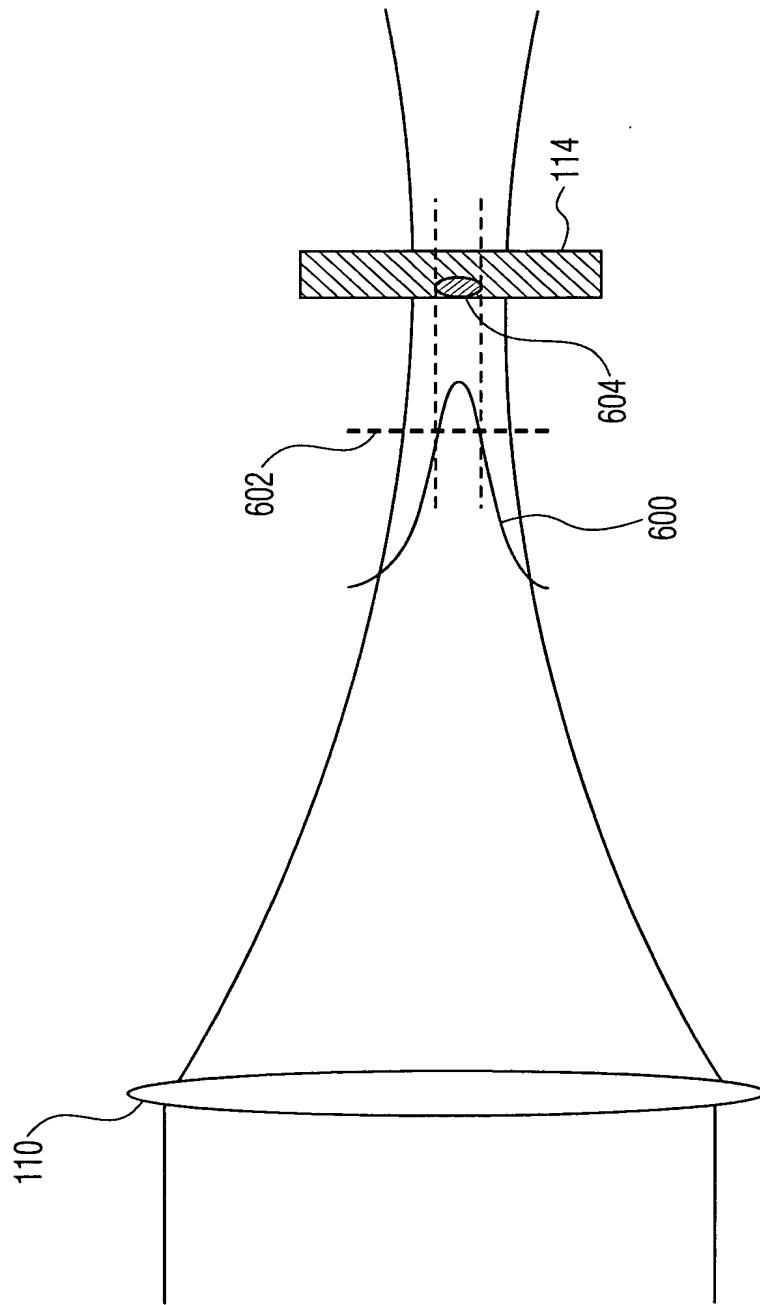


FIG. 6

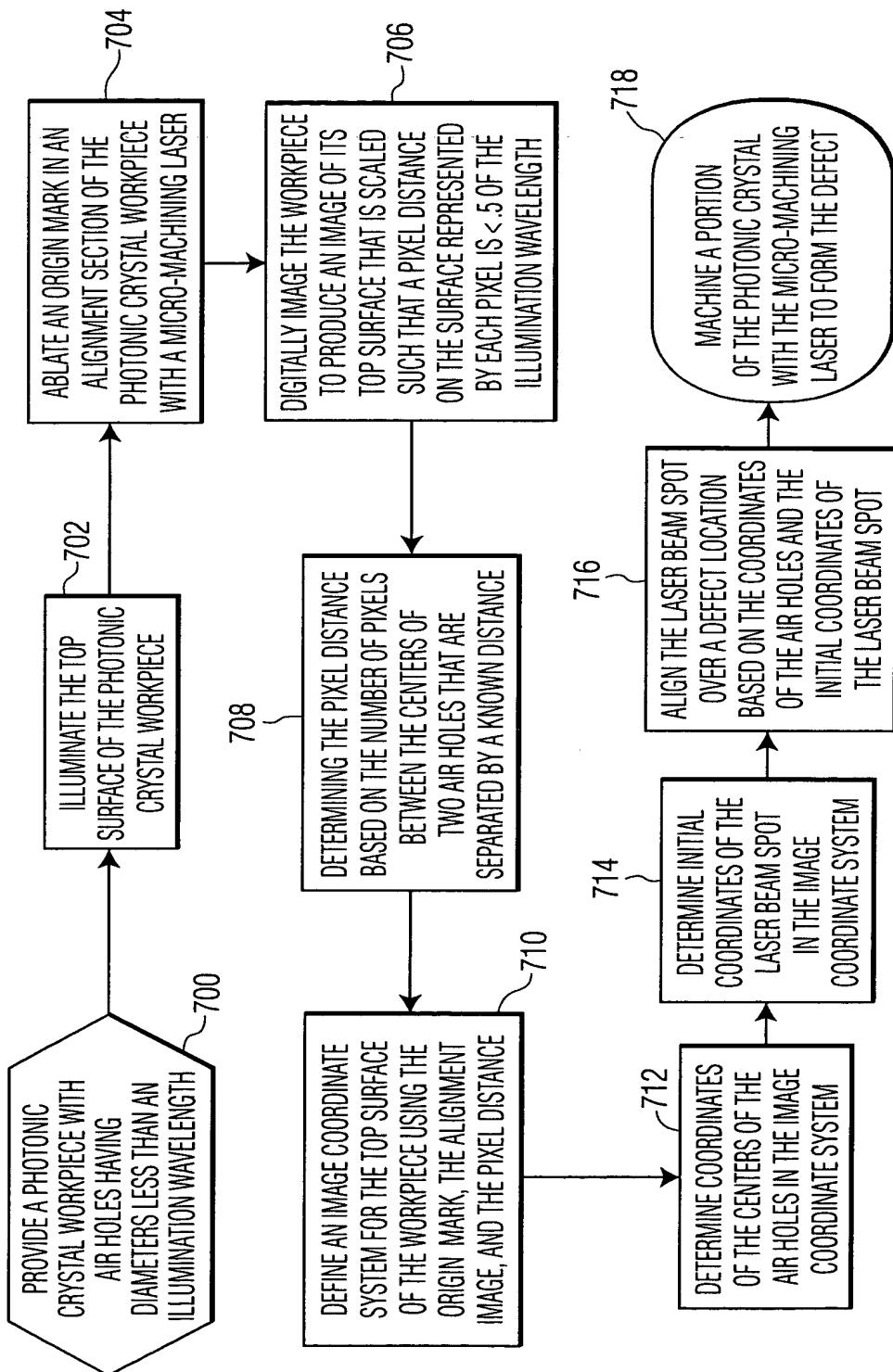
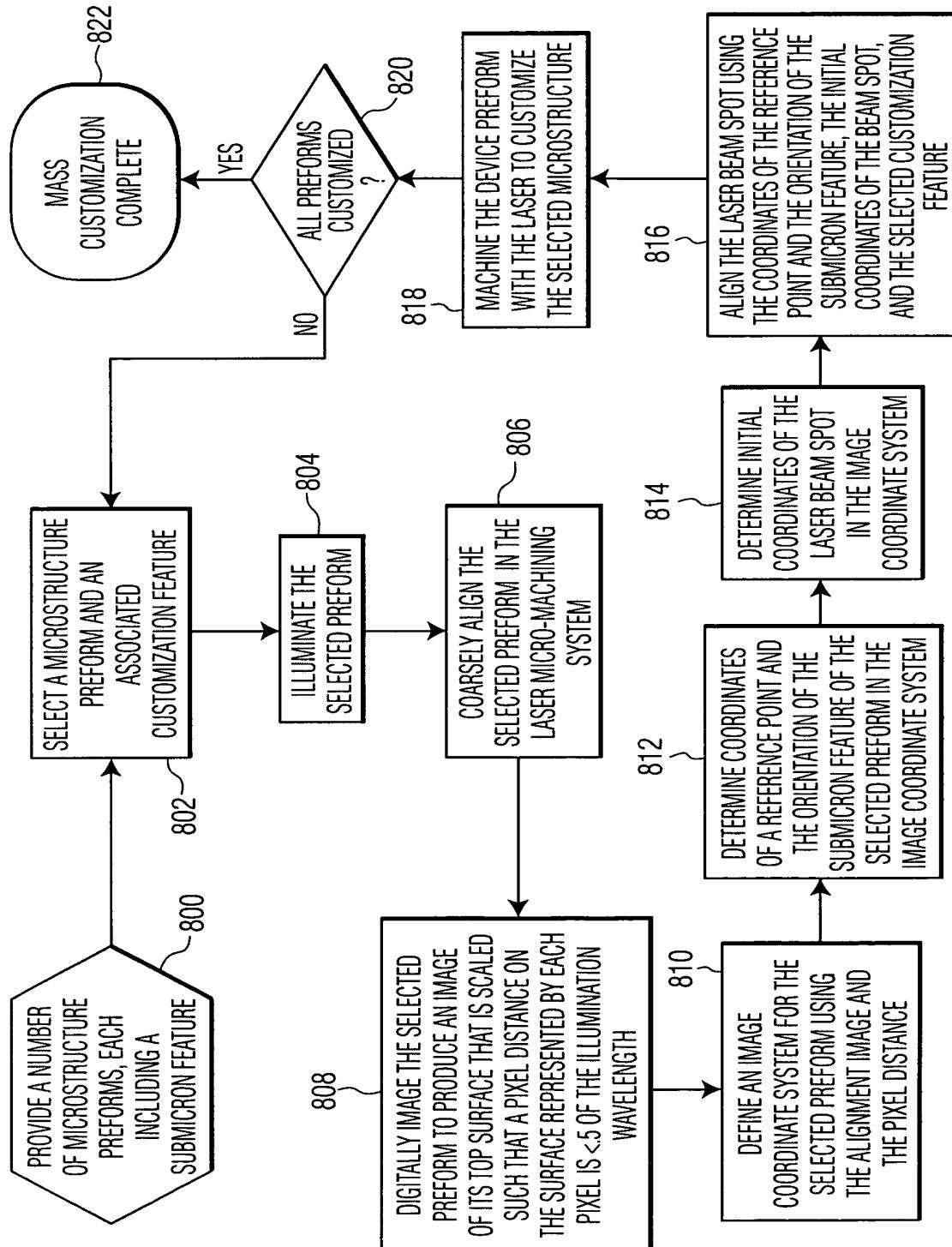


FIG. 7

**FIG. 8**



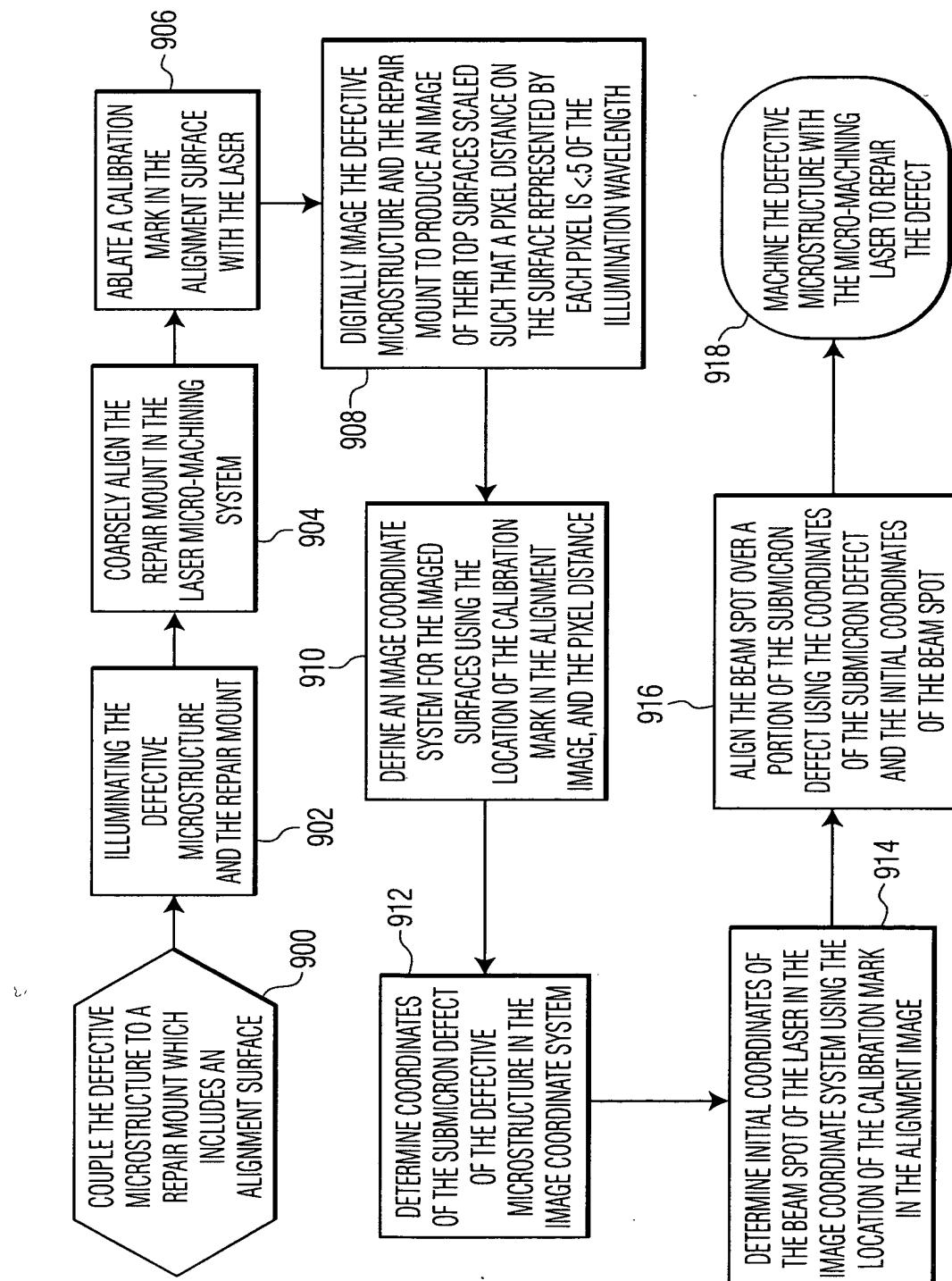


FIG. 9